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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Christoph A. Wasshuber Art Unit: 2818
Serial No.: 10/714,366 Examiner: Nguyen, T.
Filing Date: 11/13/2003 Docket No.: TI-36280
Customer No.: 23494 Conf. No.: 1864
Title: FORMING A SEMICONDUCTOR STRUCTURE IN MANUFACTURING A
SEMICONDUCTOR DEVICE USING ONE OR MORE EPITAXIAL GROWTH
PROCESSES

REQUEST FOR EXTENSION OF TIME

Commissioner of Patents
PO Box 1450
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being transmitted by
facsimile to the U.S. Patent and Trademark Office at 571-273-8300 on
the date shown below:


Jacqueline J. Garner, Reg. No. 36,144September 19, 2005
Date

Pursuant to 37 CFR 1.136(a), Applicant(s) respectfully petitions the Commissioner
for an extension of the shortened statutory period for response in the above-identified
Application.

The fee for this extension is indicated below:

- ☐ One Month (\$120)
☒ Two Months (\$450)
☐ Three Months (\$1,020)
☐ Four Months (\$1,590)

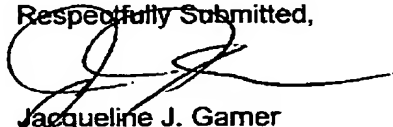
Please charge the fee to deposit account no. 20-0668. Any further necessary
extension of time is hereby requested. Charge any and all fees to deposit account no. 20-
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Respectfully Submitted,


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09/20/2005 LWDNDIM1 00000088 200668 10714366

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